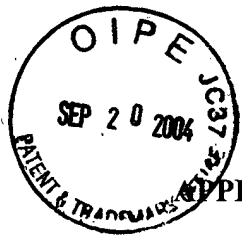


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File No. 4463  
U.S. Pat. Appln. Ser. No. 09/762,863



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Euler et al. GROUP: 2877  
SERIAL NO: 09/762,863 EXAMINER: Lee, A.  
FILED: May 2, 2001  
FOR: THIN FILM STRAIN SENSORS BASED ON  
INTER-FEROMETRIC OPTICAL MEASUREMENTS

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**RULE 312 AMENDMENT**

**IN THE SPECIFICATION:**

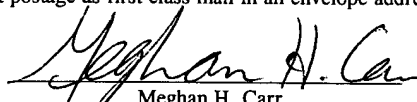
On page 1, line 3, please insert the following paragraph:

**GOVERNMENT RIGHTS**

This invention was made with U.S. Government support under Grant No. 9627265 from the National Science Foundation. The government may have certain rights in the invention.

**PRIORITY DATA**

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the Commissioner of Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

  
Meghan H. Carr  
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Date